PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT	
NATURE OF CONVEYANCE:	ASSIGNMENT	

CONVEYING PARTY DATA

Name	Execution Date
Masahiko HATA	11/04/2011
Taro ITATANI	11/21/2011

RECEIVING PARTY DATA

Name:	SUMITOMO CHEMICAL COMPANY, LIMITED	
Street Address:	27-1, Shinkawa 2-chome	
City:	Chuo-ku, Tokyo	
State/Country:	JAPAN	
Postal Code:	104-8260	

Name:	National Institute of Advanced Industrial Science and Technology	
Street Address:	3-1, Kasumigaseki 1-chome	
City:	Chiyoda-ku, Tokyo	
State/Country:	JAPAN	
Postal Code:	100-8921	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	13310614

CORRESPONDENCE DATA

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PATENT

REEL: 027328 FRAME: 0082 501744184

ATTORNEY DOCKET NUMBER:	Q128027
NAME OF SUBMITTER:	Erin Harnett, New Application Specialist
Total Attachments: 2 source=ASSIGNMENT_EXECUTED_AS_FILED#page1.tif source=ASSIGNMENT_EXECUTED_AS_FILED#page2.tif	

PATENT REEL: 027328 FRAME: 0083

ASSIGNMENT OF US NON PROVISIONAL APPLICATION

Attorney Docket	: No
Client Ref.	S23432US01
JP Atty. Ref.	SC-0044PCTUS

In consideration of the sum of Ten Dollars (\$10.00) and other good and valuable consideration paid to me as an undersigned inventor, the receipt and sufficiency of which are hereby acknowledged who at the request of, hereby sells, assigns and transfers unto:

SUMITOMO CHEMICAL COMPANY, LIMITED 27-1, Shinkawa 2-chome, Chuo-ku, Tokyo 104-8260 Japan

(hereinafter designated "ASSIGNEE") my entire right, title and interest for the United States of America as defined in 35 U.S.C. 100, in the invention and all applications including any and all divisions, continuations, substitutes, and reissues thereof; and all resulting patents, known as

SEMICONDUCTOR WAFER, PHOTOELECTRIC CONVERSION DEVICE, METHOD OF PRODUCING SEMICONDUCTOR WAFER, AND METHOD OF PRODUCING PHOTOELECTRIC CONVERSION DEVICE

for which I executed an inventor's declaration for Patent Application of the United States of America

- (A) geven date herewith
- (B) in US or International Appln. No. filed on

AND I hereby authorize and request the United States Commissioner of Patents and Trademarks to issue said Letters Patent to the said ASSIGNEE (and any other assignee, if otherwise assigned), for its interest as ASSIGNEE, its successors, assigns and legal representatives; I agree that the attorney of record in said application shall hereinafter act on behalf of said ASSIGNEE;

AND I hereby agree to testify and execute any papers for ASSIGNEE, its successors, assigns and legal representatives, deemed essential by ASSIGNEE to ASSIGNEE'S full protection and title in and to the invention hereby transferred.

I hereby authorize the US attorney of record to insert hereon any further identification necessary or desirable for recordation of this document.

	INVENTORS 発明者サイン	DATE SIGNED 目付	WITNESS 発明者サインを目視した人(省略可)
1): / Name:	Masahiko HATA	100, 4, 2011	Name:
2): Name:		***************************************	
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REEL: 027328 FRAME: 0084

ASSIGNMENT OF US NON PROVISIONAL APPLICATION

Attorney Docket N	O
Client Ref.	S23482US01
JP Atty. Ref.	SC-0044PCTUS

In consideration of the sum of Ten Dollars (\$10.00) and other good and valuable consideration paid to me as an undersigned inventor, the receipt and sufficiency of which are hereby acknowledged who at the request of, hereby sells, assigns and transfers unto:

National Institute of Advanced Industrial Science and Technology 3-1, Kasumigaseki 1-chome, Chiyoda-ku, Tokyo 100-8921 JAPAN

(hereinafter designated "ASSIGNEE") my entire right, title and interest for the United States of America as defined in 35 U.S.C. 100, in the invention and all applications including any and all divisions, continuations, substitutes, and reissues thereof, and all resulting patents, known as

SEMICONDUCTOR WAFER, PHOTOELECTRIC CONVERSION DEVICE, METHOD OF PRODUCING SEMICONDUCTOR WAFER, AND METHOD OF PRODUCING PHOTOELECTRIC CONVERSION DEVICE

for which I executed an inventor's declaration for Patent Application of the United States of America

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AND I hereby agree to testify and execute any papers for ASSIGNEE, its successors, assigns and legal representatives, deemed essential by ASSIGNEE to ASSIGNEE'S full protection and title in and to the invention hereby transferred.

I hereby authorize the US attorney of record to insert hereon any further identification necessary or desirable for recordation of this document.

J. VIII -	INVENTORS 発明者サイン	DATE SIGNED 自付	WITNESS 発明者サインを目視した人(省略可)
1): Name:	Jano Statan Taro ITATANI	Nav 2/57, 2011	Name:
2): Name:			Name:
3): Name:		,	Name:
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RECORDED: 12/05/2011